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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10081915	02/22/2002	438	129	2829	W. Fahmy

**APPLICANTS: Gonzalez Fernando; Sandhu Gurtej; Violette Miko;

Than Pham had parent

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV OF 09/570,614 05/12/2000 PAT 6,376,284
WHICH IS A DIV OF 08/604,751 02/23/1996

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed		<input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no	MCRÖ:125-4/FLE 94-0281.0
Verified and Acknowledged Examiners's Initials:			
TITLE : Method for forming conductors in semiconductor devices			
U.S.DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner		
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